



P/1596-70

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Masahiko HARUMOTO et al.
Serial No.: 10/715,817
Filed: November 17, 2003

New York, New York
Date: February 9, 2004
Group Art Unit: ---
Examiner: ---

For: SUBSTRATE TREATING METHOD AND APPARATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents P.O. Box 1450, Alexandria, VA 22313-1450, on February 9, 2004

James A. Finder

Name of applicant, assignee or
Registered Representative

Signature
February 9, 2004
Date of Signature

Respectfully submitted,

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Enclosures

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APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/715,817		OFGS File No. P/1596-70			
		Applicant Masahiko HARUMOTO et al.					
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U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class		
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	06-163352	06-1994	Japan			X	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner	Date Considered						
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